

<b>Notice of References Cited</b>	Application/Control No. 10/709,552	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Patricia A. George	Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	handbook of Semiconductor Wafer Cleaning Technology - Science, Technology, and Applications; Edited by kern, W.; Published 1993 by William Andrew Publishing/Noyes
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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